

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wei Liu
Charles M. Sorensen, Jr.

Serial No: 09/821,927

Filed: March 30, 2001

For: HYDROTREATING PROCESS AND
CATALYST

Examiner:

Group Art Unit: 1764

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.56, 1.97 - 1.98

Asst. Commissioner of Patents and Trademarks
Washington, DC 20231

Dear Sir:

The Examiner's attention is hereby directed to the following reference(s) listed on the attached Form PTO-1449 for consideration in connection with the examination of the above-identified patent application. Copies of the references were previously submitted.

Each of the reference(s) was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the enclosed documents constitute "prior art." If it should be determined that any of the submitted documents do not constitute "prior art" under United States law, applicant(s) reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicant(s) further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the enclosed references, should one or more of the references be applied against the claims of the present application.

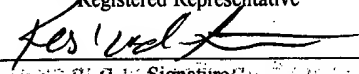
Respectfully submitted,



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Date: 10/31/01

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Asst. Commissioner of Patents and Trademarks, Washington, D.C. 20231 on <u>10/31/01</u>	
Date of Deposit	
Kees van der Sterre	
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Signature	
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